



UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani  
Serial No. : 10/657,137  
Filed : September 9, 2003  
Title : SEMICONDUCTOR INTEGRATED CIRCUIT AND FABRICATION METHOD THEREOF

Art Unit : 2811  
Examiner : Unknown

**MAIL STOP AMENDMENTS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Copies of the references listed on the attached form PTO-1449 are enclosed.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
AL	Japan 07-273349 – English Abstract: DIALOG(R) File 347: JAPIO (2004); Accession No. 04980749 and family to U.S. Patent No. 5,616,935; U.S. Patent No. 5,877,513; U.S. Patent No. 6,124,603; U.S. Patent No. 6,492,685; and U.S. Patent Application Publication No. 2003/0094656.
AM	Korea 93-0005248 – family to U.S. Patent No. 5,521,107; U.S. Patent No. 6,013,928, U.S. Patent No. 6,566,711; and U.S. Patent Application Publication No. US 2003/0173570.
AN	Korea 93-0018736 – family to U.S. Patent No. 5,485,019; U.S. Patent No. 5,849,611; U.S. Patent No. 6,147,375; and U.S. Patent No. 6,476,447.
AO	Korea 94-0016642 – family to U.S. Patent No. 5,623,157; U.S. Patent No. 5,804,878; U.S. Patent No. 6,031,290 (Desig. ID “AA”); U.S. Patent No. 6,166,414; U.S. Patent No. 6,448,612; U.S. Patent No. 6,608,353; U.S. Patent Application Publication No. US 2002/0179969; U.S. Patent Application Publication No. US 2004/0023445; and U.S. Patent Application Publication No. US 2004/0051102.

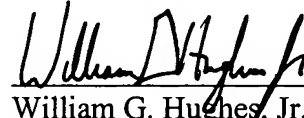
Applicant : Hisashi Ohtani  
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Filed : September 9, 2003  
Page : 2 of 2

Attorney's Docket No.: 07977-152003 / US3353D1D1

This statement is being filed before the receipt of a first Office Action on the merits.  
Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 30, 2004



William G. Hughes, Jr.  
Reg. No. 46,112

**Customer No. 26171**  
Fish & Richardson P.C.  
1425 K Street, N.W., 11th Floor  
Washington, DC 20005-3500  
Telephone: (202) 783-5070  
Facsimile: (202) 783-2331  
JFH/WXH/adt  
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Substitute Form PTO-1449

U.S. Department of Commerce  
Patent and Trademark Office

Attorney's Docket No.

07977-152003

Application No.

10/657,137

**Information Disclosure Statement  
by Applicant**

(Use several sheets if necessary)

Applicant

Hisashi Ohtani

Filing Date

September 9, 2003

Group Art Unit

2811

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,485,019	01/16/1996	YAMAZAKI et al.			02/03/1993
	AB	5,521,107	05/28/1996	YAMAZAKI et al.			03/29/1994
	AC	5,616,935	04/01/1997	KOYAMA et al.			02/01/1995
	AD	5,623,157	04/22/1997	MIYAZAKI et al.			06/07/1995
	AE	5,804,878	09/08/1998	MIYAZAKI et al.			04/24/1996
	AF	5,849,611	12/15/1998	YAMAZAKI et al.			05/31/1995
	AG	5,877,513	03/02/1999	KOYAMA et al.			01/24/1997
	AH	6,013,928	01/11/2000	YAMAZAKI et al.			06/07/1995
	AI	6,031,290	02/29/2000	MIYAZAKI et al.			03/13/1998
	AJ	6,124,603	09/26/2000	KOYAMA et al.			11/23/1998
	AK	6,147,375	11/14/2000	YAMAZAKI et al.			09/11/1998
	AL	6,166,414	12/26/2000	MIYAZAKI et al.			08/25/1999
	AM	6,448,612	09/10/2002	MIYAZAKI et al.			11/02/2000
	AN	6,476,447	11/05/2002	YAMAZAKI et al.			09/12/2000
	AO	6,492,685	12/10/2002	KOYAMA et al.			09/20/2000
	AP	6,566,711	05/20/2003	YAMAZAKI et al.			06/25/1999
	AQ	6,608,353	08/19/2003	MIYAZAKI et al.			07/12/2002

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	AR	JP07-273349	20 OCT 1995	JAPAN			Abstract	
	AS	KR93-0005248	23 MAR 1993	KOREA				No
	AT	KR93-0018736	22 SEP 1993	KOREA				No
	AU	KR94-0016642	23 JUL 1994	KOREA				No
	AV							

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-152003	Application No. 10/657,137
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Hisashi Ohtani	
		Filing Date September 9, 2003	Group Art Unit 2811

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AW	
	AX	
	AY	
	AZ	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	